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SEISHIRO YOSHIOKA ET AL.

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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Page, Etc.)

MB		- M. Hartwell et al., "Strong Electron Emission From Patterned Tin-indium Oxide Thin Films" Cambridge MA, pp. 519-521
		- M. Elinson et al., "The Emission Of Hot Electrons And The Field Emissions Of Electrons From Tin Oxide", Radio Engineering and Electron Physics, No. 7, July 1965, pp. 1290-1296

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July 9, 1992

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